

1755



Group Art Unit:-- 1755

Examiner:-- S. Coles

#3

New York, NY 10036
Date: April 3, 2002

RECEIVED
APR 9 - 2002
TC 1700

INFORMATION DISCLOSURE STATEMENT

Request is hereby made for consideration of this information disclosure statement. The following references are being cited under the provisions of 37 CFR § 1.97.

Lists references cited
by EP Examiner.

Cited by EP Examiner.

JP 60 200842

Cited by EP Examiner.

JP 06 077144

Cited by EP Examiner.

JP 08 283038

Cited by EP Examiner.

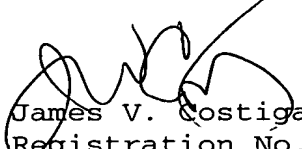
JP 06 135739

Cited by EP Examiner.

"Optical materials for
microlithography applications"
Westerhoff, T et al. The
International Society for Optical
Engineering, July 1998 pages 10-19.

Discloses the optical
performance i-line
glasses for micro-
lithography.

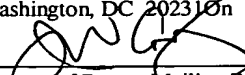
Respectfully submitted,


James V. Costigan
Registration No. 25,669

MAILING ADDRESS:
Hedman & Costigan, P.C.
1185 Avenue of the Americas
New York, NY 10036-2601
(212) 302-8989

I hereby certify that this correspondence is being
deposited with the United States Postal Service as first
class mail in an envelope addressed to:

Commissioner for Patents
Washington, DC 20231 On 4/3/02


(Signature of Person Mailing Paper or Fee)
James V. Costigan, Registration No. 25,669